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## BIB DATA SHEET

CONFIRMATION NO. 4214

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
09/620,968	07/20/2000	257	2814	0756-2183

**APPLICANTS**  
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**\*\* CONTINUING DATA \*\*\*\*\***  
 This application is a DIV of 08/857,556 05/16/1997 PAT 6,144,057  
 which is a DIV of 08/250,344 05/27/1994 PAT 5,665,210  
 which is a CON of 08/041,520 03/30/1993 ABN  
 which is a CON of 07/729,533 07/15/1991 ABN

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***  
 JAPAN 2-195174 07/24/1990  
 JAPAN 2-195175 07/24/1990  
 JAPAN 2-195176 07/24/1990

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***  
 12/15/2000

Foreign Priority claimed 35 USC 119(a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No /NATHAN W HA/ Examiner's Signature	<input type="checkbox"/> Met after Allowance NH Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 4	TOTAL CLAIMS 1	INDEPENDENT CLAIMS 1
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**ADDRESS**  
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 UNITED STATES

**TITLE**  
 Method of forming insulating films, capacitances, and semiconductor devices

FILING FEE RECEIVED 1762	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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